Chao Zhuang, Ph.D.

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Education

Ph. D. in Materials Science & Engineering, University of Tsukuba, Tsukuba, Japan. 2020 - 2023

2016 - 2019 Master in Microelectronics & Solid State Electronics, Sun Yat-sen University, Guangzhou, China.

Bachelor in Materials Physics, Sun Yat-sen University, Guangzhou, China. 2012 - 2016

Research Experience

2020 - 2023 **Ph.D. Candidate** with Prof. Genki Yoshikawa

> Materials Science & Engineering, University of Tsukuba, Tsukuba, Japan Junior Researcher, National Institute for Materials Science (NIMS), Tsukuba, Japan

- Developed a Physical Vapor Deposition (PVD) protocol to fine-tune a MEMS sensor via mechanical nonlinearity, leading to a six-fold enhancement in performance.
- · Constructed density-based topology optimization models to explore efficient MEMS sensor designs, discovering efficient designs with 30% sensitivity improvement.
- · Conducted nonlinear mechanical analysis and Fluid-Structure Interaction (FSI) simulations for the development of a novel microfluidic device.

2016 - 2019 Graduate Student with Prof. Huanjun Chen

Microelectronics & Solid State Electronics, Sun Yat-sen University, Guangzhou, China

- Synthesized metal nanoparticles and exploited their optical properties using Raman spectroscopy, enabling in-vivo sensing applications in the near-infrared window.
- Investigated metal nanoparticles' plasmonic properties through Finite Element Analysis (FEA) and the finite-difference time-domain (FDTD) method.

Skills

Proficient in English, Mandarin Chinese, Cantonese Chinese, and Japanese; Beginner Languages in French.

Computer Skills

COMSOL, OpenFOAM, MATLAB, Python, R, Mathematica, LATEX, FDTD

Technical Skills Design of Experiments, Mechanical Testing, Stylus Profilometer, Confocal Microscopy, Nanoindentation, Raman Spectroscopy, FTIR, UV-vis Spectroscopy, Darkfield Spectroscopy, SEM/EDS, PVD, TEM

Academic Experience

Awards and Achievements

Excellent Presentation Award in NIMS Student Joint Conference, Issued by NIMS Global 2022 Program Office.

Conferences

MSS Partnership, Poster Presentation. 2023

The 2nd Workshop on MSS Science & Technology, Online Presentation.

NIMS WEEK, Conference Attendance. 2022

Academic Experience (continued)

Certifications

Experimentation for Improvement. Awarded by Coursera.

Japanese Language Proficiency Test N1. Awarded by the Japan Foundation.

2018 **TOEFL iBT, 103/120**. Awarded by ETS.

Publications

Journal Articles

- K. Shiba*, **C. Zhuang**, K. Minami, G. Imamura, R. Tamura, S. Samitsu, T. Idei, G. Yoshikawa, L. Sun, and D. A. Weitz*, "Visualization of Flow-Induced Strain Using Structural Color in Channel-Free Polydimethylsiloxane Devices", *Advanced Science* 10, 2204310 (2023).
- **C. Zhuang***, K. Minami, K. Shiba, and G. Yoshikawa*, "Linear Stiffness Tuning in MEMS Devices via Prestress Introduced by TiN Thin Films", *ACS Applied Engineering Materials* 1, 1213–1219 (2023).
- **C. Zhuang***, K. Minami, K. Shiba, and G. Yoshikawa*, "Topology optimization for piezoresistive nanomechanical surface stress sensors in anisotropic (111) orientations", *Nano Express* **4**, 035007 (2023).
- Y. Xu, B. Zhou, C. Zhuang, J. Zhou*, H. Chen*, and S. Deng*, "High-Aspect-Ratio Plasmonic Heterostructures for In Vivo Enhanced Optical Coherence Tomography Imaging in the Second Near-Infrared Biological Window", *Advanced Optical Materials* 8, 2000384 (2020).
- Y. Shen, H. Chen, N. Xu, Y. Xing, H. Wang, R. Zhan, L. Gong, J. Wen, **C. Zhuang**, X. Chen, X. Wang, Y. Zhang, F. Liu, J. Chen, J. She, and S. Deng*, "A Plasmon-Mediated Electron Emission Process", *ACS Nano* 13, 1977–1989 (2019).
- **C. Zhuang**, Y. Xu, N. Xu, J. Wen, H. Chen*, and S. Deng*, "Plasmonic Sensing Characteristics of Gold Nanorods with Large Aspect Ratios", *Sensors* 18, 3458 (2018).
- J. Wen, H. Wang, W. Wang, Z. Deng, C. Zhuang, Y. Zhang, F. Liu, J. She, J. Chen, H. Chen*, S. Deng*, and N. Xu*, "Room-Temperature Strong Light–Matter Interaction with Active Control in Single Plasmonic Nanorod Coupled with Two-Dimensional Atomic Crystals", *Nano Letters* 17, 4689–4697 (2017).

Preprint

C. Zhuang*, K. Minami, K. Shiba, and G. Yoshikawa*, "Tailoring Stresses in Piezoresistive Microcantilevers for Enhanced Surface Stress Sensing: Insights from Topology Optimization", in (arXiv e-prints, Aug. 1, 2023), preprint.

In Preparation

C. Zhuang*, K. Minami, K. Shiba, and G. Yoshikawa*, "Topology optimization of piezoresistive nanomechanical sensors with integrated readout for enhanced surface stress sensing", (2023).

References

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